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(PTO-1449)

ATTY. DOCKET NO.	SERIAL NO.
67161-127	
APPLICANT: Yoshiharu ONO	
FILING DATE: November 6, 2003	GROUP

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4-Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes	Translation No
K-cc		JP 2001-358216 A	12/26/2001	MITSUBISHI DENKI KABUSHIKI KAISHA & RYODEN SEMICONDUCTOR SYSTEM ENGINEERING CORPORATION		JAPAN (w/ English Commentary on the Reference)	—

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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